

Response Under 37 CFR 1.116  
Expedited Procedure  
Examining Group 2873

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re: U.S. Patent Application 09/760,066  
Title: PROJECTION OBJECTIVE FOR MICROLITHOGRAPHY  
Applicant: Schuster  
Filed: January 12, 2001  
Art Unit: 2873  
Primary Examiner: Evelyn A. Lester  
Examiner's Phone: (571) 272-2332  
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Attorney Docket (Z) 99023 P US

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## Amendment After Final Action

Dear Examiner Lester:

This Amendment After Final Action (AAFA) responds to the Office Action  
mailed September 30, 2003.

Claims as amended in the AAFA are attached hereto.

04/01/2004 AWONDAF1 00000010 09760066

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US Patent Application 09/760,066  
(Z) 99023 P US  
Schuster

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